

Form PTO-1449 (MODIFIED)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 039153-0448 (G1153)		SERIAL NO. Unknown	
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				APPLICANT Lukanc et al.			
				FILING DATE Unknown		GROUP ART UNIT Unknown	

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U.S. PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE	
	A1	09/772,5277		Todd Lukanc			01/30/2001	
	A2	6,228,539 B1	05/08/2001	Wang et al.	430	5		
	A3	5,858,580	01/12/1999	Wang et al.	430	5		
	A4	5,807,649	09/15/1998	Liebmann et al.	430	5		
	A5	5,573,890	11/12/1996	Spence	430	311		
		6,534,224	1/30/2001	LUKANC	430	5		
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	A6	Levenson et al., "Improving Resolution in Photolithography with a Phase-Shifting Mask," IEEE Transactions On Electron Devices, Vol. ED-29, No. 12, December 1982, pp. 1828-36.						
	A7	Lin, B. J., "Phase-Shifting Masks Gain an Edge," Circuits & Devices, March 1993, pp. 28-35.						
EXAMINER				DATE CONSIDERED				
				9/10/03				
* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include any copy of this form with next communication to applicant.								